



CERTIFICATE



This is to certify that

Veeco Instruments Inc.

1 Terminal Drive, Plainview, NY 11803 United States of America

with the organizational units/sites as listed in the annex

has implemented and maintains a Quality Management System.

Scope:

The provision of Ion Beam and Etch, MOCVD, Laser Annealing, Lithography and Wet Etch & Clean technologies, equipment and related services where thin film deposition and precision nanomaterials processing play an integral role in the fabrication and packaging of advanced semiconductor devices.

Through an audit, documented in a report, it was verified that the management system fulfills the requirements of the following standard:

ISO 9001 : 2015

Certificate registration no.	10018220 QM15
Date of original certification	2020-08-25
Date of certification	2024-03-25
Valid until	2027-04-21



DQS IS A MEMBER OF





David Tellez Managing Director

DQS Inc.





Annex to certificate Registration No. 10018220 QM15

Veeco Instruments Inc.

1 Terminal Drive, Plainview, NY 11803 United States of America

Location

10001029 Veeco Instruments Inc. 355 East Trimble Road San Jose, CA 95131 United States of America

10018212

Veeco Instruments Inc. 185 Gibraltar Road Horsham, PA 19044 United States of America

10018220 Veeco Instruments Inc. 1 Terminal Drive Plainview, NY 11803 United States of America

10018221 Veeco Instruments Inc. 145 Belmont Drive Somerset, NJ 08873 United States of America

10018222 Veeco Instruments Inc. 394 Elizabeth Ave. Somerset, NJ 08873 United States of America

10018223 Veeco Instruments Inc. 22 Roosevelt Ave. Somerset, NJ 08873 United States of America

Scope

The provision of Laser Annealing and Lithography technologies, equipment, and related services where thin film deposition and precision nano-materials processing play an integral role in the fabrication and packaging of advanced semiconductor devices.

The provision of Wet Etch & Clean technologies, equipment, and related services where thin film deposition and precision nano-materials processing play an integral role in the fabrication and packaging of advanced semiconductor devices.

The provision of Ion Beam and Etch and Wet Etch & Clean technologies, equipment, and related services where thin film deposition and precision nano-materials processing play an integral role in the fabrication and packaging of advanced semiconductor devices.

The provision of Ion Beam and Etch and MOCVD technologies, equipment, and related services where thin film deposition and precision nano-materials processing play an integral role in the fabrication and packaging of advanced semiconductor devices.

The provision of Ion Beam and Etch and MOCVD technologies, equipment, and related services where thin film deposition and precision nano-materials processing play an integral role in the fabrication and packaging of advanced semiconductor devices.

Somerset Warehouse (Shipping and Receiving), Incoming Quality Assurance.

This annex (edition: 2024-03-25) is only valid in connection with the above-mentioned certificate.